Receipt date: 11/21/2007

10582588 - GAU: 2827

PTO/SB/08 Equivalent

	Application No.	10/582,588
INFORMATION DISCLOSURE	Filing Date	June 9, 2006
STATEMENT BY APPLICANT	First Named Inventor	Williams et al.
STATEMENT BY APPLICANT	Art Unit	Unknown 2827
(Multiple sheets used when necessary)	Examiner	Unknown C.Y.
SHEET 1 OF 1	Attorney Docket No.	DAVI258.003APC

U.S. PATENT DOCUMENTS					
Examiner Initials Cite No. Document Number Number - Kind Code (if known) Example: 1,234,567 B1		Publication Date MM-DD-YYYY Name of Patentee or Applicant		Pages, Columns, Lines Where Relevant Passages or Relevant Figures Appear	
	1	4,586,164	04-29-1986	Eden Dayton D	

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Examiner Initials	Cite No.	Foreign Patent Document Country Code-Number-Kind Code Example: JP 1234567 A1	Publication Date MM-DD-YYYY	Name of Patentee or Applicant	Pages, Columns, Lines Where Relevant Passages or Relevant Figures Appear	
	2	JP 60 180886	09-14-1985	Fujitsu Ltd.		

NON PATENT LITERATURE DOCUMENTS				
Examiner Initials Cite No. Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume-issue number(s), publisher, city and/or country where published.		T¹		
	3	KAILER A. et al., "Phase transformations of silicon caused by contact loading" © 1997 American Institutes of Physics: J Appl. Phys. Vol. 81, No. 7,1 April 1997, pgs 3057-3063		
	4	Suppl. European Search Report, EP 04 80 2037, Date: 6/28/2007.		

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Examiner Signature /Connie Yoha/ Date Considered 02/15/2010

^{*}Examiner: Initial if reference considered, whether or not citation is in conformance with MPEP 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.